

ELI LCS Overview

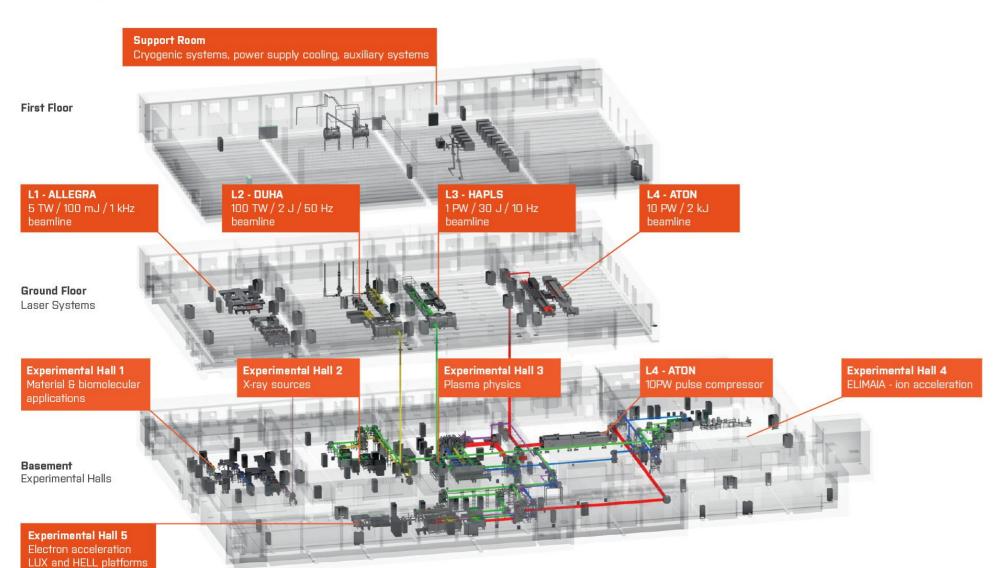
Petr Mazůrek Birgit Plötzeneder







ELI Beamlines in a nutshell





User operations since 2019



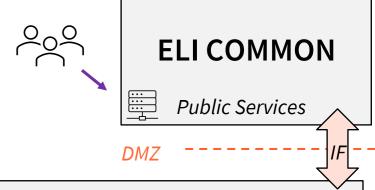


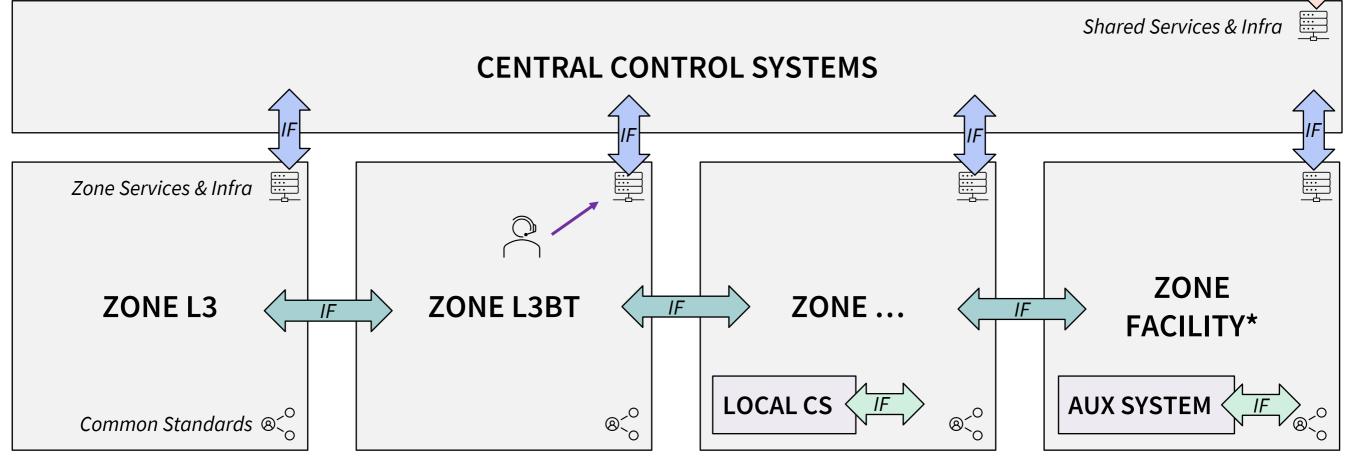




Hierarchy of ELI-BL Control & DAQ Systems

Our systems are divided into **zones**; with **standardized services, infrastructure, solutions. Standard interfaces** connect zones to central services and infrastructure, and eventually to publicly accessible services.













Laser Control Systems

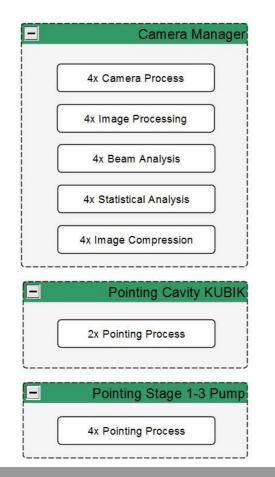


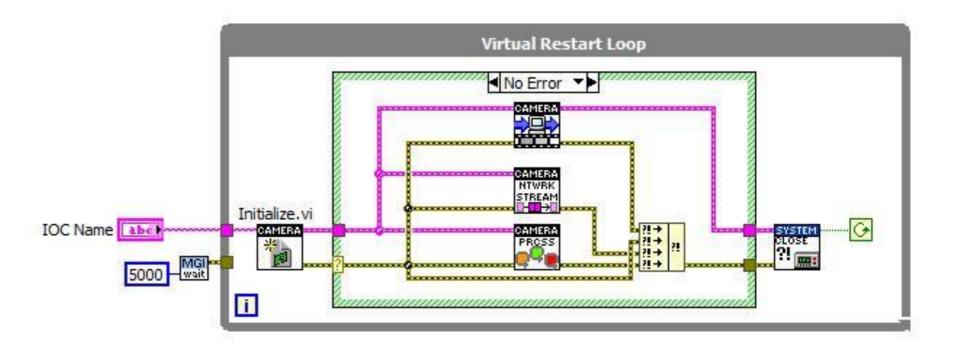




Scope of the architecture

- Each RMC contains several Input-Output Controllers (IOC)
- Each IOC contains processes











Communication protocols

AMC (Asynchronous Message Communication)

- UDP based
- Sending commands from Developer GUIs to IOCs

Network Streams

- Handle reliable transfers on top of modified TCP/IP
- Used for developer GUIs
- Streams are wrapped into the architecture

CA (Channel Access)

- Used by EPICS 3.14, client compatible with EPICS 7 (ca only)
- Enables transfer of data using TCP/IP with additional features







FPGA

- NI 9149 is the most common type (Ethernet RIO)
- Programmatic interaction with FPGA front panel for slow data
- FIFOs for fast data
- Both DAQ and state machine control are applicable on FPGA





RT

- Supported OS: ETS PharLap, NI RT Linux, Win10
- RMC 8354 (matured)
- KISS 1U Short V3 CFL
 - Intel i7-9700E (8Core/2,6GHz)
 - 8GB DIMM DDR4 2666
- Real-time controllers can be virtualized





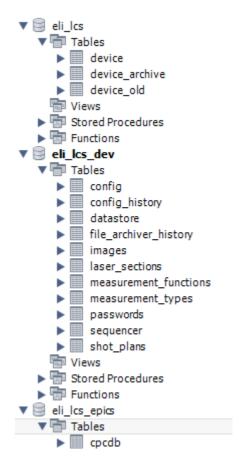


Integration: Databases (1/2)

Database contains information about all the PVs and IOCs

id	pv_name	cp_ta	gra device_id	ioc_id	datastore_id	pv_t	ds_type	nelm	pv_class
802	L1-FE-PM01:VAL_CAL			EDS	EDS-Zone 0:CH1 Data	ΑI			LABIOC_AI
803	L1-FE-PM24:VAL_CAL	NULL	RMC123	EDS	EDS-Zone 0:CH2 Data	AI	DBL	NULL	LABIOC_AI
804	L1-FE-PM04:VAL_CAL	NULL	RMC123	EDS	EDS-Zone 0:CH3 Data	ΑI	DBL	NULL	LABIOC_AI

- PVs require server information
- IOCs require INI and CFG configurations that define their functionality

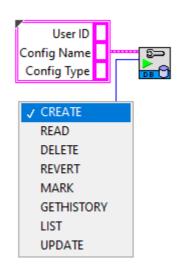






Integration: Databases (2/2)

Database access is provided using DB Config Access.vi



 Configuration history can then be used to backtrack in time what changes might have had an effect on the system

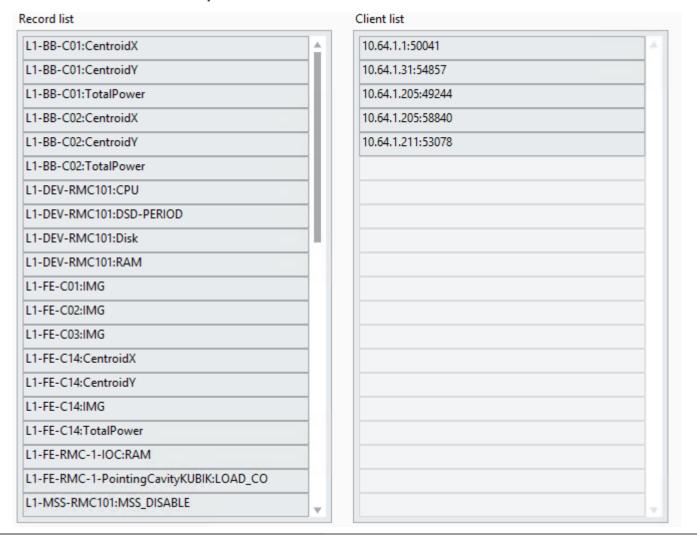




Integration: EPICS

Data is published using a LabIOC server which is present on all machines









User Interfaces

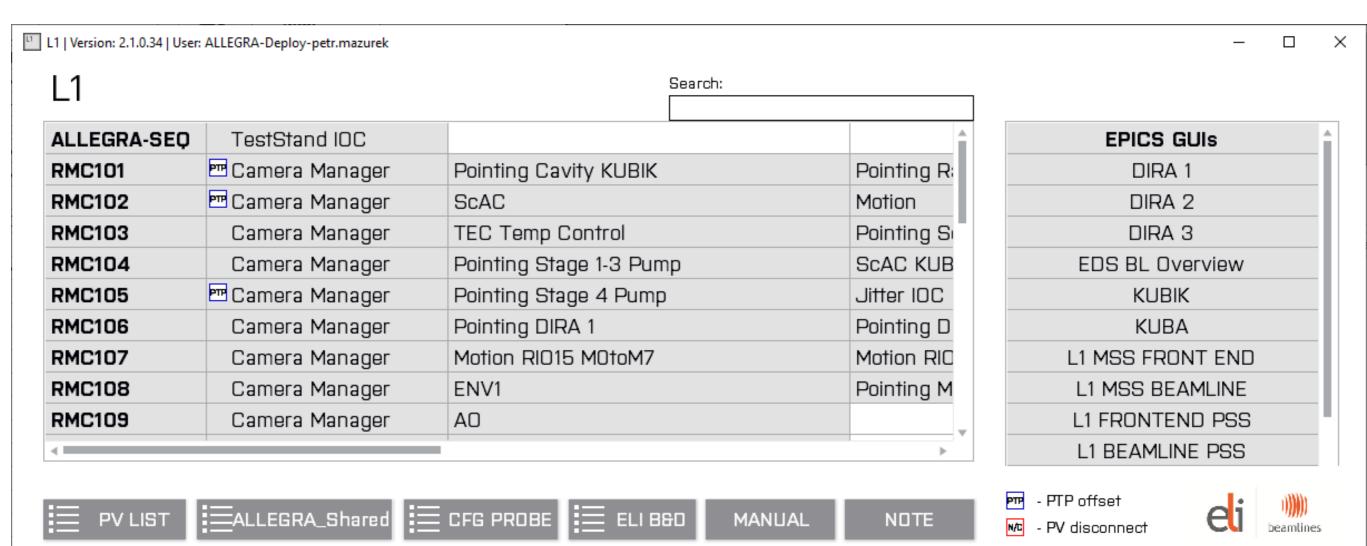










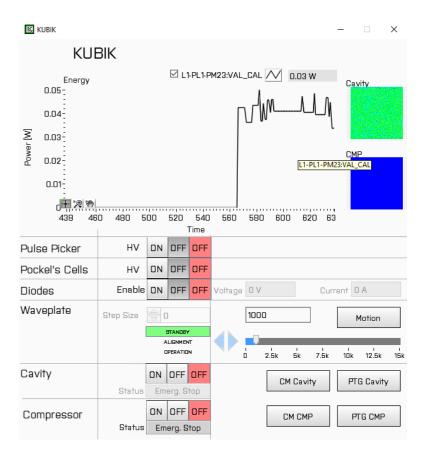






- EPICS GUIs use a special template that defines their appearance but allows various PVs to be added as data sources
- This is stored in the database and it is modifiable using an editor

Control Name	PV linked				
Fundamental Spectrum	L1-PL1-PM23:VAL_CAL				
GUI Name					
PC Status	L1-FE-L1_1-BB-PL1-RA-PC-HV:HV-on_RBV				
PC Off	L1-FE-L1_1-BB-PL1-RA-PC-HV:HV-on				
PC On	L1-FE-L1_1-BB-PL1-RA-PC-HV:HV-on				
Diodes	L1-FE-L1_1-BB-PL1-RA-LH-PL-PS:Out_Enable_RBV				
Diodes OFF	L1-FE-L1_1-BB-PL1-RA-LH-PL-PS:Out_Enable				
Diodes ON	L1-FE-L1_1-BB-PL1-RA-LH-PL-PS:Out_Enable				





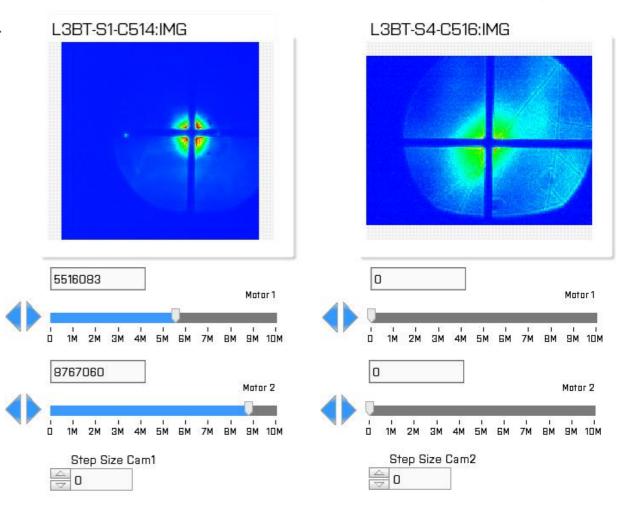


GUIs (3/5)

- Process data -> IOC -> EPICS
- EPICS GUIs allow access to multiple IOCs through EPICS layer

E3 Alignment

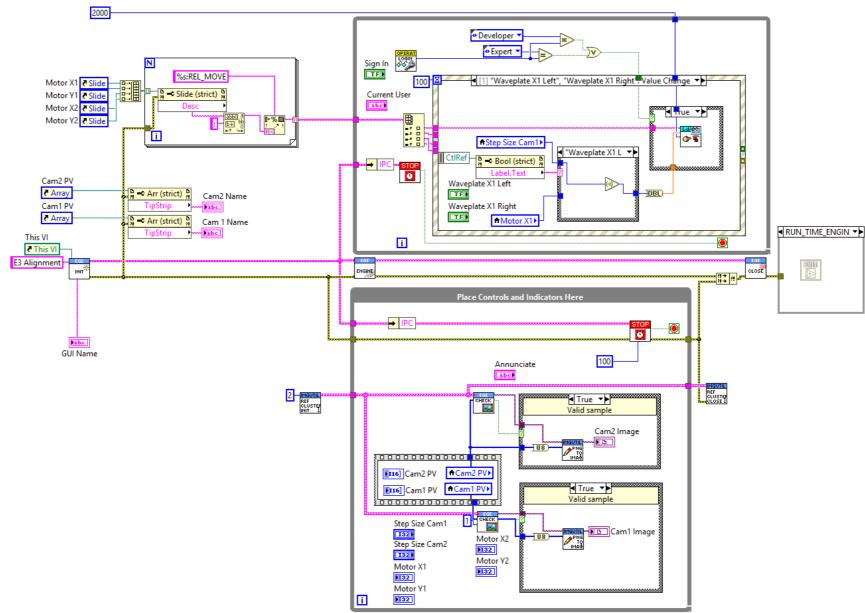










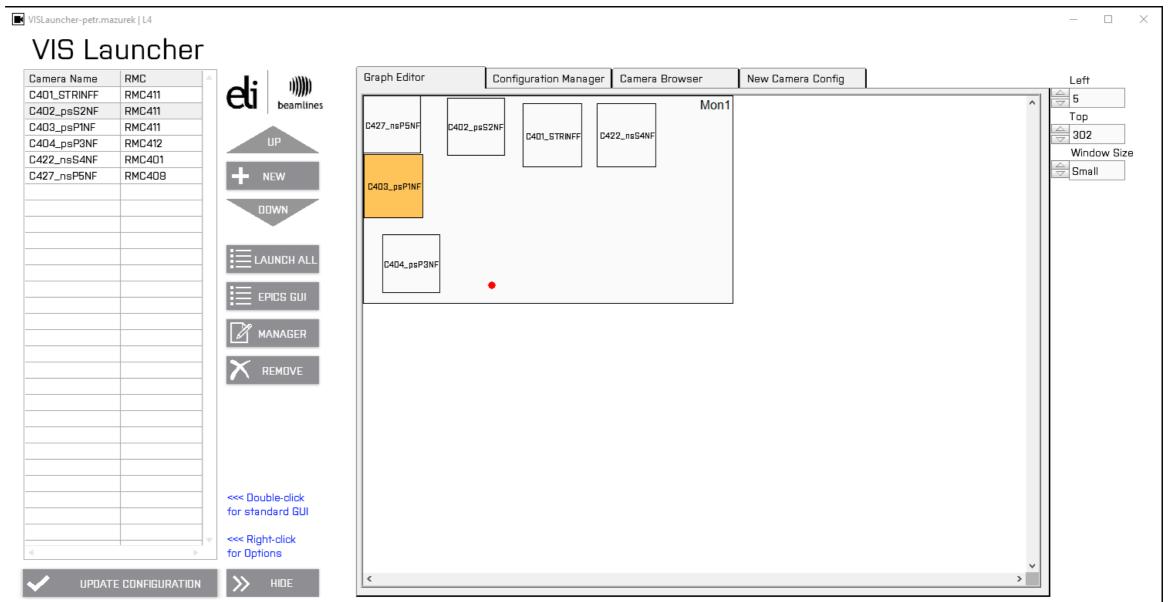








GUIs (5/5)









Deployment

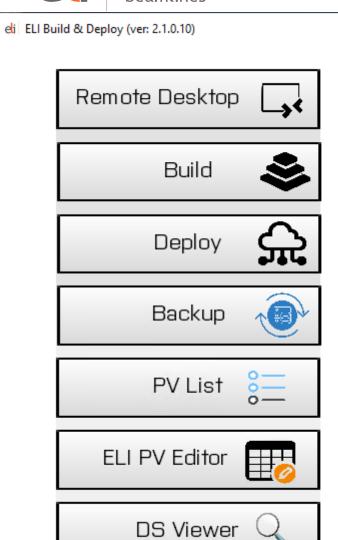


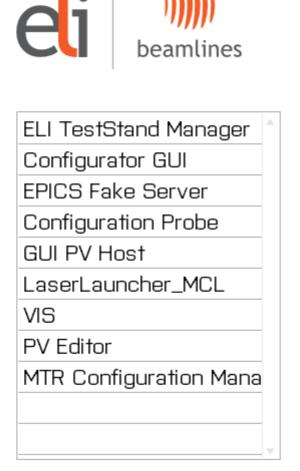






Build and Deploy tool





RMC103

RMC104

RMC105

RMC106

RMC107

RMC108

RMC109

RMC110

RMC111

RMC112

RMC113

RMC114

RMC115

\L1\Deployment\RMC103.lvproj

\L1\Deployment\RMC104.lvproj

\L1\Deployment\RMC105.lvproj

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\L1\Deployment\RMC107.lvproj

\L1\Deployment\RMC108.lvproj

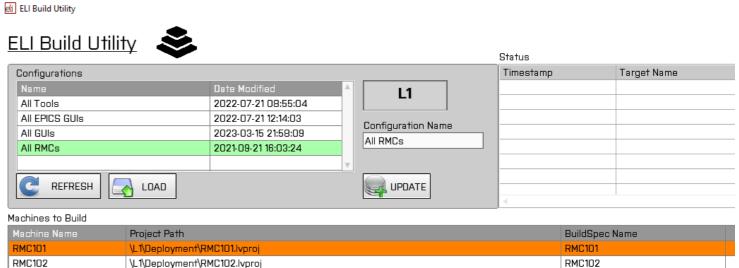
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\L1\Deployment\RMC112.lvproj

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RMC103

RMC104

RMC105

RMC106

RMC107

RMC108

RMC109

RMC110

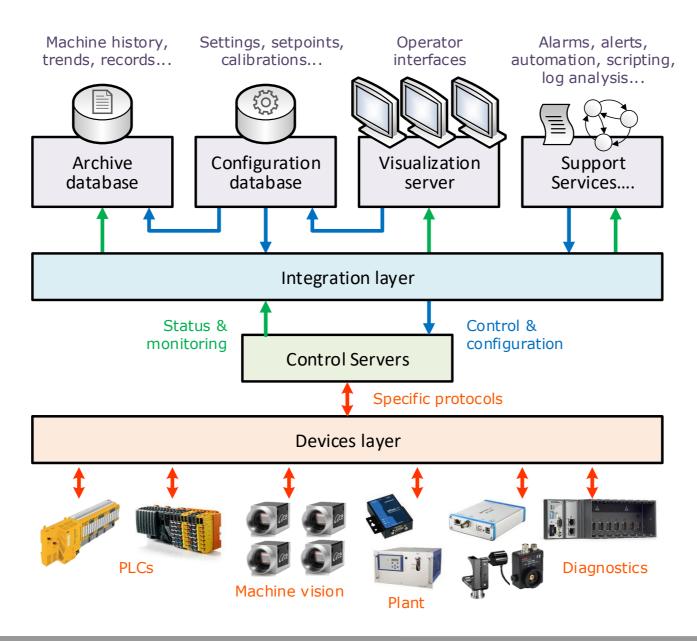
RMC111

RMC112

RMC113



Zone Architecture







See you around!

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www.eli-beams.eu















